



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoya SUNACHI et al.

Group Art Unit: 2811

Application No.: 10/812,036

Filed: March 30, 2004

Docket No.: 119318

For: SEMICONDUCTOR LIGHT-EMITTING ELEMENT AND MANUFACTURING
METHOD THEREOF

CLAIM FOR PRIORITY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested for the above-identified patent application and the priority provided in 35 U.S.C. §119 is hereby claimed:

Japanese Patent Application No. 2003-345709 filed October 3, 2003

In support of this claim, a certified copy of said original foreign application:

☒ is filed herewith.

It is requested that the file of this application be marked to indicate that the requirements of 35 U.S.C. §119 have been fulfilled and that the Patent and Trademark Office kindly acknowledge receipt of this document.

Respectfully submitted,

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Date: August 5, 2004

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